



Patent  
Attorney's Docket No. 015290-500

UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of )  
S. Y. LI et al. ) Group Art Unit: 1763  
Application No.: 09/820,695 ) Examiner: A. W. Olsen  
Filed: March 30, 2001 ) Confirmation No.: 4162  
For: METHOD OF PLASMA ETCHING )  
LOW-K DIELECTRIC MATERIALS )  
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AMENDMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Official Action mailed September 27, 2005, please amend  
the above-identified patent application as follows:

12/08/2005 JADD01 00000019 09820695  
01 FC:1202 50.00 OP